

<b>Notice of References Cited</b>	Application/Control No. 10/049,212	Applicant(s)/Patent Under Reexamination LEE ET AL.	
	Examiner Vivian Chen	Art Unit 1773	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-5,273,657	12-1993	Nakashima et al.	210/640
	C	US-5,514,461	05-1996	Meguro et al.	428/310.5
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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